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Sheet **1** of **1**

Complete if Known

Application Number	10/563,701
Filing Date	January 5, 2006
First Named Inventor	Andreas Seifert et al.
Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned
Attorney Docket Number	1210/95954

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
/RDS/	1	US 3,254,556	06/07/1966	J.J.J. Staunton	
	2	US 4,195,913	04/01/1980	Dourte et al.	
	3	US 4,277,141	07/07/1981	Kleiber	
	4	US 5,837,082	11/17/1998	Gräfe	
	5	US 6,166,868	12/26/2000	Holderer et al.	
	6	US 2002/0021507	02/21/2002	Melzer et al.	
/RDS/	7	US 2003/0058555	03/27/2003	Takino	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code-Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ³
/RDS/	7	GB 577,059	05/02/1946	John H. McLeod et al.		
	8	EP 1 296 162	03/26/2003	Nikon Corporation		
	9	DE 197 35 831	02/25/1999	Zeiss Carl FA		
	10	JP 2000-098108	04/07/2000	Nippon Kogaku KK		
/RDS/	11	JP 2000-098110	04/07/2000	Nippon Kogaku KK		
	12	JP 2000-098011	04/07/2000	Nikon Corp.		
/RDS/	13	JP 2000-098112	04/07/2000	Nippon Kogaku KK		
/RDS/	14	JP 2000-098113	04/07/2000	Nikon Corp.		
/RDS/	15	JP 2000-098114	04/07/2000	Nikon Corp.		
	16	JP 2000-131220	05/09/2000	Nikon Corp.		
/RDS/	17	JP 2000-339058	12/08/2000	Agilent Technologies Inc.		
	18	JP 2000-162414	06/16/2000	Nikon Corp.		
	19	JP 2000-162416	06/16/2000	Nippon Kogaku KK		
/RDS/	20	JP 60-060618	04/08/1985	Toshiba Corp.		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ³
/RDS/	21	Article entitled "Fabrication Methods for Precision Optics," Author: Hank H. Karov, (Dated 1993, Wiley, New York, Article No. XP002298986, pp. 560-562)	

Examiner Signature	/Ricky D. Shafer/	Date Considered	11/22/2008
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